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Advances in Applied Ceramics: Structural, Functional and Bioceramics Modelling and experimental measurements of the mechanical response of piezoelectric structures from millimeter to micrometer --Manuscript Draft--

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Abstract:	Laser interferometry techniques have shown their ability to assess the mechanical response of a piezoelectric thin film. To support these investigations, a numerical study based on the finite element method is carried out: three dimensional modellings of piezoelectric samples from bulk materials to thin films are examined. For each considered sample, a time dependent analysis and a frequency domain study are performed. By performing time dependent analysis, we obtain effective piezoelectric coefficient, d33, of the samples. Frequency domain study helps to calculate the frequency response of these samples. The calculated d33 values and the first frequency resonance values are then compared with the experimental data.

Modelling and experimental measurements of the mechanical response of piezoelectric structures from millimeter to micrometer

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Modelling of the mechanical response of piezoelectric structures from millimeter to micrometer

Laser interferometry techniques have shown their ability to assess the mechanical response of a piezoelectric thin film. To support these investigations, a numerical study based on the finite element method is carried out: three dimensional modellings of piezoelectric samples from bulk materials to thin films are examined. For each considered sample, a time dependent analysis and a frequency domain study are performed. By performing time dependent analysis, we obtain effective piezoelectric coefficient, d33, of the samples. Frequency domain study helps to calculate the frequency response of these samples. The calculated d33 values and the first frequency resonance values are then compared with the experimental data.

Keywords: Piezoelectric material; Laser interferometry; Numerical modelling; Finite element method; Functional characterization; Impedancemetry

Introduction

Nowadays, piezoelectric materials have many applications in the fields of industry, medicine and research. Thin piezoelectric materials are important for developing MEMS devices [1], [2] such as autonomous wireless sensor network [3] and implanted medical devices [4]. Thereby, the research in the field of piezoelectric materials and in that new micro-electromechanical devices are getting much more inter-related. In this context, integrated structures based on the piezoelectric thin films are widely investigated and their characterisations become a crucial issue in the development of new applications. In the case of bulk material, resonance or out of resonance methods can be used to assess the material properties. The conventional static characterisation methods use the direct piezoelectric effect [5]. A static stress on the material generates a charge quantity on both faces of the material, which is measured, and the piezoelectric coefficient is determined. When applied to thin films, the method requires nanopositioning system to apply a uniform normal external stress on the sample. If not, the

consequence can be a bending of the structure leading to an incorrect measurement and a possible fracture of the sample. Inverse piezoelectric effect can also be used. In this case one has to measure the mechanical displacement for a given voltage. Today laser based interferometer has sensitivity less than 1 nm/V endowing displacement measurements on thin films possible [6]–[8].

This work addresses the development of a three dimensional (3D) modelling tool based on the finite element method (FEM) to support a laser based technique to characterize the mechanical response of piezoelectric samples in a quasistatic regime [9]. Different piezoelectric samples are here studied from millimeter size to micrometer size. Firstly, theoretical considerations on the determination of the effective piezoelectric coefficient, d_{33} , of the active electro-material are briefly reported. Then, the different experimental setups used for the calculation of the frequency measurement and the effective piezoelectric coefficient measurement are presented. Finally, 3D FEM models are implemented for each investigated sample which enable the comparison of numerical to experimental results.

1 Theoretical considerations

The piezoelectric constitutive equations [10], [11] are defined as follows:

$$S_{\alpha} = S_{\alpha\beta}^{E} T_{\beta} + d_{i\alpha} E_{i}$$
 (1)

$$D_i = d_{i\alpha}T_{\alpha} + \varepsilon_{ij}^T E_j$$
 (2)

$$\alpha, \beta = 1, \dots, 6$$
 $i, j = 1, 2, 3$

These equations relate the mechanical strain and electrical displacement (respectively S_{α} and D_i) to the stress and electrical field (respectively T_{β} and E_j) where $S_{\alpha\beta}^E$ is the compliance tensor at constant electric field, $d_{i\alpha}$ is the piezoelectric tensor and ε_{ij}^T the

permittivity tensor at constant stress. Figure 1 shows the orientation of the ceramic defined by α , β , i and j.

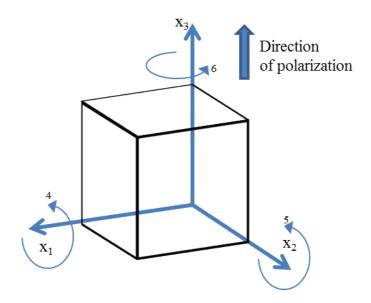


Figure 1 Notation of crystal axes with polarization direction

Equations (3), (4) and (5) are obtained from expanding the tensor notation.

$$S_1 = S_{11}^E T_1 + S_{12}^E T_2 + S_{13}^E T_3 + d_{31}E_3$$
 (3)

$$S_3 = S_{13}^E(T_1 + T_2) + S_{33}^ET_3 + d_{33}E_3$$
 (4)

$$D_3 = \varepsilon_3^T E_3 + d_{31}(T_1 + T_3) + d_{33}T_3$$
 (5)

We consider a piezoelectric thin film deposited on an isotropic substrate and poled along the x_3 direction. Then it is necessary to consider the clamping effects induced by other adjacent materials on the thin film. We assume that the displacement in axes 1 and 2 is negligible ($S_1 = S_2 = 0$) and that the substrate is the dominant element ($T_1 = T_2 = T$). With no applied stress, $T_3 = 0$, we get

$$d_{33}^{eff} = d_{33} - 2d_{31} \frac{s_{13}^E}{(s_{11}^E + s_{12}^E)}$$
 (6)

Then, equation (6) gives the value of the effective electro-mechanical coefficient \mathbf{d}_{33} . As referred from the analysis made by K. Lefki and G.J.M Dormans [5], this value is equal to the ratio of the elongation Δl of the sample in axis 3 to the applied voltage V.

By inverse effect, when exposed to an AC electric field, a piezoelectric ceramic element changes dimensions cyclically at the cycling frequency of the field. This electric field produces a vibration whose amplitude corresponds to the displacement of the sample. Hence, with the help of equation (1) and for excitation frequencies much lower than the first cutoff frequency of the device, we can obtain d_{33}^{eff} as

$$d_{33}^{eff} = \frac{\Delta l}{V} = \frac{v}{U_{in} \times 2 \times \pi \times f_{in}}$$
 (7)

where v is the normal velocity vibration of the piezoelectric sample, and U_{in} and f_{in} respectively the amplitude and the frequency of the sinusoidal input signal.

2 Experimental approach

The frequency at which the ceramic element vibrates most readily, and converts the electrical energy input into mechanical energy most efficiently, is the resonance frequency. At this particular frequency the admittance in an electrical circuit describing the sample is maximum. A Bode 100 Omicron impedance analyser is used to determine the frequency response of each investigated element (Figure 2).

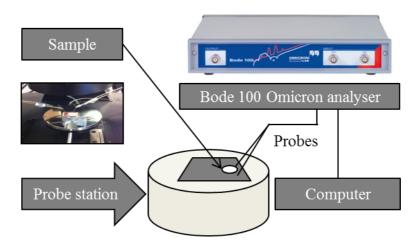


Figure 2 Bode 100 Omicron analyser setup

Then, the mechanical response of a sample in a quasistatic regime is obtained by measuring the displacement of its top surface by a laser setup (Figure 3) in a frequency range below the first resonance. The sample is placed on a probe station, connected to

an Agilent 33250A function generator and illuminated through a binocular microscope by a Polytec laser interferometer connected to its scanning system and controller. The laser set up allows displacement measurements of 50 nm/V or velocity measurements of 5mm/s/V. The demodulated laser signals and the excitation signals can be simultaneously visualized on a Lecroy 6050A oscilloscope.

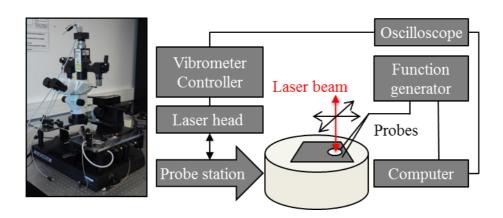


Figure 3 Laser setup

The whole experimental setup is controlled by a computer thanks to a Labview program which generates the input signals, acquires the output signals and performs the post-processing in Matlab. This post-treatment uses equation (7) to give the mean value of the calculated d_{33}^{eff} in pm/V for N demanded measurements (typically N=10).

Measurements are carried out on four different samples presented in Figure 4: a PZ27 ceramic rod, dimensions 2x2x15mm; a PZ27 ceramic disc, 20mm diameter and 2mm thick; a LiNbO₃Y+36 single crystal, 12mm diameter and 0,5mm thick; a PZT thin film. This thin film consists of 240 nm PbZr_{0.52}Ti_{0.48}O₃ film deposited by sol-gel method obtained from STMicroelectronics (Tours, France) [12] [13] and Pt electrodes deposited by PVD (Physical Vapor Deposition) sputtering. Circular structures with diameters varying from 50μm to 1600μm were fabricated by conventional optical lithography and ion beam etching method. To allow the numerical study on an experimentally exploitable sample size, only the 400μm capacitors were considered.

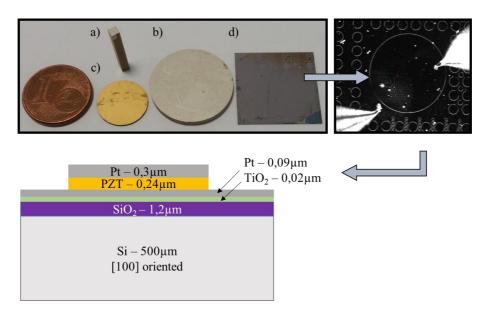


Figure 4 Investigated samples: a) PZ27 rod b) PZ27 disc c) LiNbO₃Y+36 single crystal d) PZT thin film

The Lithium Niobate sample, supplied by Roditi International Corporation Ltd., is used as reference sample as its properties are well investigated and reported in the literature data [14], [15]. The frequency response of this sample is presented in Figure 5. Its first occurring resonance (f_{rl}) is measured at 324,2kHz.

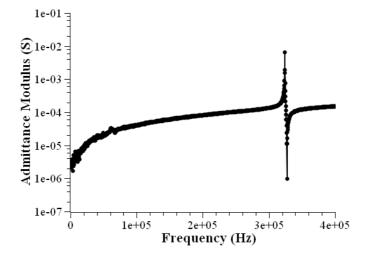


Figure 5 Frequency response of the LiNbO₃Y+36 single crystal

For each sample, Table 1 presents the value of the frequency of the first occurring resonance (f_{rI}) in kHz and of the d_{33}^{eff} in pm/V at 10kHz.

Table 1 Experimental measurements

SAMPLE	f_{rl} (kHz)	d ^{eff} ₃₃ (pm/V) @ 10kHz
PZ27 rod	92,8	402,1
PZ27 disc	114,9	6,9
LiNbO ₃ Y+36 single crystal	324,2	34,8
PZT thin film	8884	99,1

Both of the PZ27 ceramic samples were manufactured by Meggitt-Ferroperm. Concerning the rod, the nominal value of its d_{33} given by the manufacturer is 425pm/V. We therefore have a discrepancy of 5,39% which can be explained by the variability of the ceramic properties from a batch to another.

3 Numerical modelling

To complete our experimental approach, a numerical study based on the finite element method is carried out with COMSOL Multiphysics® FEA software with the Structural Mechanics and the AC/DC modules.

COMSOL software has a special section of Material Library (based on the "Material Property Database (MPDB)," JAHM Software, Inc.) where numerous materials are available with their standard properties as Lithium Niobate. For PZ27, the properties have been taken from the Meggitt-Ferroperm's material data based on typical values. In the particular case of the thin film, the modelling of the 400µm capacitor has been lightened to the single piezoelectric layer considered made of PZ27. It has been done to limit the mesh size, to help the convergence and to stay in reasonable calculation times. For each considered sample, a frequency domain analysis is firstly performed in a given frequency range to determine the quasistatic regime of the sample. A 3D modelling of the sample with free mechanical boundary conditions at its ends is built. The bottom surface in the model is grounded and an AC voltage source of amplitude 1V is applied on the top surface at the current frequency. The intensity is calculated at the terminals

of the sample and finally the electrical admittance is deduced for each studied frequency by application of the generalized Ohm's law. For each sample, Table 2 gives information on the mesh.

Table 2 Mesh information

SAMPLE	type	number of elements	number of points
PZ27 rod	quadrangular	475	720
PZ27 disc	triangular	696	585
LiNbO ₃ Y+36 single crystal	triangular	348	390
PZT thin film	triangular	214	248

Secondly, a time dependant analysis is done to obtain the normal displacement on the top surface of the sample: the bottom surface of the model is grounded and a sinusoidal electric potential (with parameters equivalent to the experimental excitation signal) is applied at its top surface. In the particular case of the thin film, the substrate clamping is taken into account by a fixed constraint mechanical boundary condition at the bottom surface of the piezoelectric layer. With the help of the displacement values obtained at the top surface of the sample, the piezoelectric coefficient (d_{33}) is calculated from equation (7).

From the simulations, we then obtain the value of the frequency of the first occurring resonance in kHz and of the d_{33}^{eff} in pm/V. For each sample, these results are reported in Table 3.

Table 3 Numerical results

SAMPLE	$f_{rl}\left(\mathrm{kHz}\right)$	d ₃₃ ^{eff} (pm/V) @ 10kHz
PZ27 rod	98,4	423
PZ27 disc	125,3	7,4
LiNbO ₃ Y+36 single crystal	321,5	36,3

PZT thin film 7960 116

Concerning the rod, we notice a discrepancy of 0,47% with the nominal value of its d_{33} given by the manufacturer.

Figure 6 presents the frequency response of the LiNbO3Y+36 single crystal obtained by numerical modelling compared to its experimental curve. Compared to the experiment, there is a difference of less than 1% in frequency. The amplitude mismatching between the two curves could be reduced by a better appreciation of the actual tensors of the material [16].

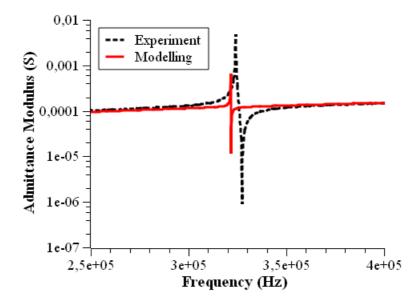


Figure 6 Frequency response of the LiNbO3Y+36 single crystal: experiment vs. modelling

4 Discussion

Table 4 presents for each sample the percentage of difference between experimental and modelling results.

Table 4 Experiment vs. modelling

SAMPLE -	$f_{rl}\left(\mathrm{kHz} ight)$	d_{33}^{eff} (pm/V)
	Δ (%)	$\Delta\left(\% ight)$

PZ27 rod	6	4,9
PZ27 disc	9	5,9
LiNbO ₃ Y+36 single crystal	0,83	4,1
PZT thin film	10,4	14,5

Finally, the discrepancy between modelling and experiment is less than 15%. This discrepancy increases as the size of piezoelectric film decreases from millimeter to micrometer. In case of thick films, the whole geometry is reduced to a piezoelectric layer, whereas for thin films, many layers such as platinum electrodes, titanium dioxide, silicon dioxide and silicium wafer are present.

Thus, number of parameters such as contribution of additional layers or substrate clamping are not well taken into account. Indeed, for these samples the measured d_{33}^{eff} parameter is related to the bulk d_{33} parameter by equation (6) depending on the unclamped mechanical compliances of the piezoelectric film and on the unclamped transverse piezoelectric coefficient. Likewise, the substrate bending during measurement can also influence the measurements [17] [18] especially when done on large diameter electrodes.

In addition, bulk material data were taken for calculation while it is well known that in the case of thin film the different material tensors are very often modified due to microstructural differences (mostly in grain size) and to enhanced interfacial effects generated by the reduced dimensionality [19] [20].

Furthermore, the accuracy in the results can be limited by the precise knowledge of the elastic, dielectric and piezoelectric properties of the piezoelectric material too. The characterization step is mainly performed by experiments on test samples using the IEEE standard method [21]. Usually, the manufacturer conducts this characterization step, offering a unique database, with the error measurements, regardless of the shape or a specific batch of each kind of piezoelectric ceramic or single crystal [22]. Even if these values are determined with a relatively good accuracy (often a maximum of $\pm 10\%$), a significant difference can appear between the simulations and the actual behavior for a piezoelectric sample. One rising approach to determine the properties of piezoelectric materials are the FEM-based methods . Most of them adjust the theoretical electrical impedance curve to fit with the experimental one: an automatic algorithm is implemented to find the material properties that minimize the difference between the

numerical impedance curve and the experimental one, in a given frequency range [16], [23]–[28].

At last, the samples have ben modelled in mechanical free boundary conditions even if they are in reality laid down on a platinum and that tungsten tips are used to resumption of electrical contact.

Conclusion

The ability to predict the mechanical response of piezoelectric samples from finite element modelling has been demonstrated and compared to experimental data. The first resonance values and the d_{33} values obtained from this first modelling step are in a good agreement with the experimental ones for the milimetric sized samples. 10 to 15 % differences between these values are obtained in the micrometric sized sample indicating that other effects such as substrate clamping and contribution of additional layers should be better taken into account both experimentally and numerically. The consideration of these effects will be the subject of a future work.

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